IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s):

Jeffrey W. Carr

Appln. No.:

10/608,384

Confirm. No.: 7970 Filed: June

June 27, 2003

Title:

Apparatus and Method for Reactive Atom

Plasma Processing for Material Deposition

PATENT APPLICATION

Art Unit:

1765

Examiner:

Vinh, Lan

Docket No.

CARR-1000US4

Customer No. 23910

CERTIFICATE OF TRANSMISSION/MAILING UNDER 37 C.F.R. § 1.8

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USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Patricia A Diahl

(Signatur

Patricia A. Diehl

Signature Date: _____

REPLY TO OFFICE ACTION UNDER 37 C.F.R. § 1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

This Reply is in response to the Office Action dated December 15, 2005.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.

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Any. Docket No.: CARR-01000US4 SRM/DTX
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